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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/046,497	10/26/2001	Er-Xuan Ping	MTI-31041-A	8624	
22202 75	7590 03/15/2005		EXAMINER		
WHYTE HIRSCHBOECK DUDEK S C			LE, TH	LE, THAO X	
555 EAST WE SUITE 1900	LLS STREET		ART UNIT	PAPER NUMBER	
MILWAUKEE	, WI 53202		2814		

DATE MAILED: 03/15/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

				A?			
		Application No.	Applicant(s)				
		10/046,497	PING ET AL.				
	Office Action Summary	Examiner	Art Unit				
		Thao X. Le	2814				
Period fo	The MAILING DATE of this communication or Reply	appears on the cover sheet wit	h the correspondence addre	ss			
THE - Exte after - If the - If NC - Failu Any	ORTENED STATUTORY PERIOD FOR REMAILING DATE OF THIS COMMUNICATIOnsions of time may be available under the provisions of 37 CFI SIX (6) MONTHS from the mailing date of this communication period for reply specified above is less than thirty (30) days, a period for reply is specified above, the maximum statutory perior to reply within the set or extended period for reply will, by streply received by the Office later than three months after the med patent term adjustment. See 37 CFR 1.704(b).	ON. R 1.136(a). In no event, however, may a re n. a reply within the statutory minimum of thirty riod will apply and will expire SIX (6) MONT tatute, cause the application to become ABA	ply be timely filed (30) days will be considered timely. HS from the mailing date of this commitance. ANDONED (35 U.S.C. § 133).	unication.			
Status							
1)	Responsive to communication(s) filed on 1	5 February 2005.					
2a) □		This action is non-final.					
3) 🗌	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.						
Disposit	ion of Claims						
5)□ 6)⊠ 7)□	Claim(s) 101-116 and 123-224 is/are pend 4a) Of the above claim(s) 101-116,123-142 Claim(s) is/are allowed. Claim(s) 143-155,167-193 and 196-224 is/Claim(s) is/are objected to. Claim(s) are subject to restriction are	<u>,156-166,194 and 195</u> is/are w are rejected.	ithdrawn from consideration	1.			
Applicat	ion Papers						
10)	The specification is objected to by the Exan The drawing(s) filed on is/are: a) Applicant may not request that any objection to Replacement drawing sheet(s) including the column the oath or declaration is objected to by the	accepted or b) objected to be the drawing(s) be held in abeyand rrection is required if the drawing(s	ce. See 37 CFR 1.85(a). s) is objected to. See 37 CFR 1				
Priority ι	under 35 U.S.C. § 119						
12) [a) [Acknowledgment is made of a claim for fore All b) Some * c) None of: 1. Certified copies of the priority docum 2. Certified copies of the priority docum 3. Copies of the certified copies of the papplication from the International Bu See the attached detailed Office action for a	. nents have been received. nents have been received in Appriority documents have been reau (PCT Rule 17.2(a)).	oplication No received in this National Sta	ige			
Attachmen		o □	Immoru (DTO 442)				
2) 🔲 Notic 3) 🔯 Inform	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449 or PTO/SB r No(s)/Mail Date <u>02/15/05</u> .	Paper No(s)	ummary (PTO-413) /Mail Date formal Patent Application (PTO-15 _·	2)			

DETAILED ACTION

Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 2. Claims 143-145, 147, 149-155, 167-193, 196-202 are rejected under 35 U.S.C. 102(b) as being anticipated by US 5483094 to Sharma et al.

Regarding claims 143, 182, 186, 197, 201, Sharma discloses a semiconductor structure in fig. 12, comprising at least two overlying crystal 33/34 of epitaxial silicon (ES), abstract and column 3 line 42, column 8 line 5, each ES crystal comprising a top surface, and sidewalls,), and insulative materials 41/61, column 4 line 64, column 5 line 29 over the sidewalls, the top surface defining a facet (top surface of crystal 34 comprises a facet); an uppermost ES crystal 34 of the at least two overlying crystals having a layer of an insulative material 41 over the top surface, fig. 12, wherein the structure is disposed on a substrate 10, column 3 line 18, in a vertical orientation, fig. 12.

Regarding to claims 144-145, 147, Sharma discloses the semiconductor structure wherein the insulative crystal 41/61 comprises an oxide, column 4 line 66, wherein the insulative crystal comprises a silicon nitride, column 5 lines 29-32.

Regarding to claims 149, 190, 196, 198, 202, Sharma discloses a semiconductor structure in fig. 12, comprising at least two overlying crystals 33/34 of ES, each ES crystal comprising a top surface, and sidewalls, and insulative materials 41/61, fig. 12, over the sidewalls, the top surface defining a facet (top surface of layer 34 comprises a facet), an uppermost ES crystal 34 of the at least two overlying crystals 33/34 having a layer of an insulative material 41 over the top surface, one or more of the ES crystals comprising a conductivity enhancing dopant, column 3 lines 45-52, wherein the structure is disposed on a substrate in a vertical orientation.

Regarding claims 150-153, Sharma discloses the conductivity enhancing dopant comprising a p-type dopant, which is selected from the group consisting of boron, wherein the conductivity enhancing dopant comprising a n-type dopant, which is selected from the group consisting of phosphine, column 4 lines 12-17.

Regarding claims 154-155, Sharma discloses the semiconductor structure wherein one or more of the ES crystals comprises a concentration gradient of the dopant within the ES crystal, wherein the concentration gradient comprises a low to high concentration of the dopant within the ES, with the high dopant concentration at the top surface of the crystal, column 3 line 55-67.

Regarding claims 167-172, 174-175, 177, 178, 180-181, 183-185, 187-189, 191-193 Sharma discloses the semiconductor structure being a component of a transistor, being a transistor gate, being a S/D diffusion region, fig. 12, column 8 line 7, column 3 lines 46-48,

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Regarding to claims 173, 176, 199, Sharma discloses a semiconductor structure in fig. 12, comprising at least two overlying crystals 33/34 of epitaxial silicon (ES), column 3 line 42, each ES crystal comprising a top surface, and sidewalls, and insulative materials 41/61, column 4 line 64, over the sidewalls, the top surface defining a facet (top surface of layer 34); an uppermost ES crystal 34 of the at least two overlying crystals having a top surface with an overlying crystal of an insulative material 41/61, wherein the structure is disposed on a substrate in a vertical orientation, wherein the structure being a component of a transistor, fig. 12, column 8 line 7.

Regarding to claims 179, 200, Sharma discloses a semiconductor structure in fig. 12, comprising at least two overlying crystals 33/34 of ES, each ES crystal comprising a top surface, and sidewalls, and insulative materials 41/61, fig. 12, over the sidewalls, the top surface defining a facet (top surface of layer 34 comprises a facet), an uppermost ES crystal 34 of the at least two overlying crystals 33/34 having a layer of an insulative material 41 over the top surface, one or more of the ES crystals comprising a conductivity enhancing dopant, column 3 lines 45-52, wherein the structure is disposed on a substrate in a vertical orientation, and the structure being a component of a transistor, fig. 12 column 8 line 7.

3. Claims 203-223 rejected under 35 U.S.C. 102(b) as anticipated by or, in the alternative, under 35 U.S.C. 103(a) as obvious over US 5483094 to Sharma et al.

Regarding claims 203-223, as discussed in the claims 143, 149,173, 176, 179, 182, 186, 190, 196, 197-202 above, Sharma discloses the all the claimed structure limitations in claims 203-223. Claims 203-223 are product-by-process, thus all the

<u>process limitations</u> in claims 203-223 do not carry weight in a claim drawn to structure. In re Thorpe, 277 USPQ 964 (Fed. Cir. 1985).

Claim Rejections - 35 USC § 103

- 4. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

5. Claims 146, 148 are rejected under 35 U.S.C. 103(a) as being unpatentable over US 5483094 to Sharma et al.

Regarding claims 146 and 148, Sharma does not expressly disclose the thickness of the insulative layer about 5 to 20 nm or 2 to 5 nm.

However, Sharma reference discloses an insulative layer 41/61 has a general thickness in fig. 12. Accordingly, it would have been obvious to one of

ordinary skill in art to use thickness teaching Sharma in Kim device in the range as claimed, because it has been held that where the general conditions of the claims are discloses in the prior art, it is not inventive to discover the optimum or workable range by routine experimentation. See In re Aller, 220 F.2d 454, 105 USPQ 233, 235 (CCPA 1955).

6. Claim 224 is rejected under 35 U.S.C. 103(a) as being unpatentable over US 5483094 to Sharma et al. in view of US 5849077 to Kenney.

Regarding claim 224, Sharma does not disclose the semiconductor structure wherein the top surface of at lest one of epitaxial silicon crystal defines a face having a (100) plane orientation.

However, Kenney discloses a semiconductor structure in fig. 1m wherein the top surface of at lest one of epitaxial silicon crystal 19 defines a facet having a (100) plane orientation, column 4 line 39. The silicon substrate 1 is having a (100) plane orientation, column 4 line 11; thus the epitaxial layer 19 is having the same orientation. At the time the invention was made; it would have been obvious to one of ordinary skill in the art to use the (100) plane orientation 19 teaching of Kenney in Sharma's device, because the (100) plane orientation is greatly dominated the market as taught by Kenney, column 2 lines 28-30.

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Conclusion

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7. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thao X. Le whose telephone number is (571) 272-1708. The examiner can normally be reached on M-F from 8:00 AM - 4:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Wael M. Fahmy can be reached on (571) 272 -1705. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Thao X. Le 10 Mar. 2005